



12-03-02

AP/2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicant: Peter Van Buskirk, et al.
Application No.: 09/200,495
Date Filed: November 25, 1998
Title: OXIDATIVE TOP
ELECTRODE DEPOSITION
PROCESS, AND
MICROELECTRONIC
DEVICE STRUCTURE

Docket No.: 2771-337 RCE
Examiner: S. Hu
Art Group: 2811
Confirmation No.: 4898



25559

PATENT TRADEMARK OFFICE

#24/E
Amend
J. Mcmillon
12/18/02
Entry
3/27/03
[Signature]

EXPRESS MAIL CERTIFICATE

I hereby certify that I am mailing the attached documents to the Commissioner for Patents on the date specified, in an envelope addressed to the Commissioner for Patents, Box AF, Washington, D.C., 20231 and Express Mailed under the provisions of 37 CFR 1.10.

Dennis Maxwell

Signature

December 2, 2002

Date

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**RESPONSE TO SEPTEMBER 30, 2002 OFFICE ACTION
IN U.S. PATENT APPLICATION NO. 09/200,495**

Box AF
Commissioner for Patents
U.S. Patent and Trademark Office

Sir:

In response to the Office Action dated September 30, 2002 in the above-identified patent application, please amend the application as follows: